

Docket No.: S1432-700819

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

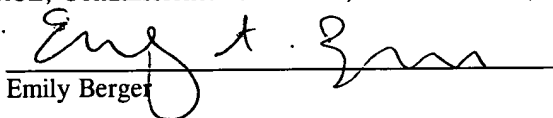
Applicant: Yeshwanth Narendar et al.  
Serial No: 10/752,434  
Confirmation No: 3742  
Filed: January 6, 2004  
For: HIGH PURITY SILICON CARBIDE ARTICLES AND METHODS

Examiner: Karl E. Group  
Art Unit: 1755

---

**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 13<sup>th</sup> day of December, 2006.

  
Emily Berger

---

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the final Office Action mailed July 13, 2006, please amend the above-identified application as follows. Changes to the Claims are shown by strike through for deleted matter and underlining for added matter.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.